

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

FUJII et al.

Allowed: September 13, 2001

Batch No.: L96

Appln. No.: 09/749,693

Group Art Unit: 2856

Examine: Kwok

Filed: December 28, 2000

Title: SEMICONDUCTOR MECHANICAL SENSOR

Date: December 6, 2001

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INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents
Washington, D.C. 20231

Sir:

Attached is Form PTO-1449 listing the enclosed.

I hereby certify that each enclosed document listed on the herewith Form PTO-1449 was cited in the attached Japanese Official Action sent November 20, 2001, issued in a counterpart foreign application not more than three months ago.

This IDS is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Respectfully submitted,

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